

Application/Control No.	Applicant(s)/Patent und Reexamination	ler
10/537,760	ZHA ET AL.	
Examiner	Art Unit	
Krishnan S. Menon	1797	

SEARCHED					
Class	Subclass	Date	Examiner		

INT	INTERFERENCE SEARCHED				
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
Inventor search; 210/321.69, 321.321.79,321.8,321.88, 321.89, 636, 221.2,	6/23/2008	KM		
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